



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of

Hideki IWAKI *et al.*

Serial No. 09/994,683

Filed: 28 November 2001

For: MULTI-LEVEL CIRCUIT SUBSTRATE,  
METHOD FOR MANUFACTURING  
SAME AND METHOD FOR ADJUSTING  
CHARACTERISTIC IMPEDANCE  
THEREFOR

Art Unit: 2812

Examiner: Leonardo ANDUJAR

Attorney Docket: P64916US1

5/Election  
JHREBW  
6/6/03  
RECEIVED  
MAR 25 2003  
TECHNOLOGY CENTER 2800

RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Applicant in response to the Office Action dated 26 February 2003 (Paper No. 4), hereby elects Claim 1 through 11 for further prosecution in this application.

An early and favorable action is respectfully solicited.

Respectfully submitted,  
JACOBSON HOLMAN, PLLC

Date: 24 March 2003

Customer No. 000,136  
400 Seventh Street, N.W.  
Washington, D.C. 20004  
(202) 638-6666

By

Nathaniel A. Humphries  
Nathaniel A. Humphries  
Registration No. 22,772

by [Signature]  
Reg. No. 28,264

Attorney Docket: P64916US1